Electronic Acknowledgement Receipt					
EFS ID:	1120591				
Application Number:	10790492				
Confirmation Number:	9512				
Title of Invention:	Atomic layer deposition of capacitor dielectric				
First Named Inventor:	Lingyi A. Zheng				
Correspondence Address:	DINSMORE & SHOHL LLP  One Dayton Centre  Suite 500  One South Main Street  Dayton OH 45402-2023  US 9372230724				
Filer:	Matthew A Molloy/Vicki Hebbard				
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## File Listing:

Number Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Amendment - After Non-Final Rejection	MIO0082N2amendment.pdf	386864	no	10
Warnings:					
Information	1				

This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.

Total Files Size (in bytes):

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## New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

## National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.